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## Nano-optical imaging of WSe<sub>2</sub> waveguide modes revealing light-exciton interactions

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We report on a nano-optical imaging study of WSe<sub>2</sub> thin flakes with scanning near-field optical microscopy (NSOM). The NSOM technique allows us to visualize in real space various waveguide photon modes inside WSe<sub>2</sub>. By tuning the excitation laser energy, we are able to map the entire dispersion of these waveguide modes both above and below the *A* exciton energy of WSe<sub>2</sub>. We found that all the modes interact strongly with WSe<sub>2</sub> excitons. The outcome of the interaction is that the observed waveguide modes shift to higher momenta right below the *A* exciton energy. At higher energies, on the other hand, these modes are strongly damped due to adjacent *B* excitons or band-edge absorptions. The mode-shifting phenomena are consistent with polariton formation in WSe<sub>2</sub>.

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Group VI transition-metal dichalcogenides (TMDCs) with chemical formula  $MX_2$  (M = Mo, W; X = S, Se, Te) are novel semiconductors with layered structures and remarkable (opto)electronic properties [1–4]. Light-matter interactions in this class of materials have been widely explored in the far-field regime where many intriguing optical phenomena due to excitons were observed by emission and reflection/absorption spectroscopy [3–20]. Recently, a few near-field emission studies of TMDCs were reported where nanoscale photoluminescence responses due to grain boundaries were observed [21,22]. Nevertheless, more work needs to be done on near-field reflection/absorption studies that address finite-momentum light-matter interactions. Here we perform near-field nano-optical imaging studies of WSe2 thin flakes in the reflection mode by using aperture-type near-field scanning optical microscopy (NSOM). With this technique, we directly excited finite-momentum waveguide photon modes inside TMDCs and studied their interactions with excitons without the need of additional momentum coupling methods.

The samples studied in our work are thin flakes of tungsten diselenide (WSe<sub>2</sub>)—a prototypical TMDC [17–19]. The direct excitons of bulk WSe<sub>2</sub> are located around 1.57 eV (*A* excitons) and 2.03 eV (*B* excitons) corresponding to excitation wavelengths ( $\lambda_0$ ) of about 790 and 610 nm, respectively (Fig. S3; see the Supplemental Material [23]). As illustrated in Figs. 1(a) and 1(b), a laser beam is delivered through the NSOM tip with an aperture of ~100 nm in diameter to excite the WSe<sub>2</sub> sample underneath the tip. Our laser is a tunable Ti:sapphire oscillator operating in the continuous-wave mode that covers a wide spectral range in the visible and near-infrared regime (700–950 nm). We collect all the reflected or scattered photons through an objective (NA = 0.45) above the sample [Fig. 1(b)] and these photons are counted with an avalanche photodiode (Supplemental Material [23]). Throughout the imaging experiments, we keep the tip and objective fixed and only scan the sample stage. The NSOM collects both the topography and near-field optical images simultaneously at ambient conditions.

The sample investigated in Fig. 1 is a  $WSe_2$  flake with a thickness of 260 nm sitting on a standard SiO<sub>2</sub>/Si wafer (Fig. S1 [23]). By tuning  $\lambda_0$ , we are able to perform spectroscopic nanoimaging of the WSe<sub>2</sub> sample. The selected dataset of the near-field images is shown in Figs. 1(c)-1(f), where we plot the normalized photon counts. We first consider the near-field image taken at  $\lambda_0 = 900 \text{ nm}$  [Fig. 1(c)]. Here, we observe bright fringes on both WSe<sub>2</sub> and SiO<sub>2</sub> parallel to the sample edge (white dashed line), but the fringe pattern and intensity are clearly different on the two materials. Compared to the fringes on SiO<sub>2</sub>, those on WSe<sub>2</sub> are stronger in intensity and more densely distributed. Moreover, the fringes on WSe<sub>2</sub> extend further away from the sample edge and demonstrate no significant damping. As a result, we are able to see fringes (upper right corner) due to a remote edge of WSe<sub>2</sub> that is not present within the field of view (Fig. S1b [23]). As  $\lambda_0$  decreases [Figs. 1(d)-1(f)], the intensity of the fringes on WSe<sub>2</sub> drops rapidly indicating that their damping becomes significantly larger at shorter  $\lambda_0$ . Eventually at  $\lambda_0 = 760$  nm [Fig. 1(f)], the fringes almost disappear in the interior of the sample. In contrast, fringes on SiO<sub>2</sub> show more subdued variations with  $\lambda_0$ .

The observed fringe patterns on both WSe<sub>2</sub> and SiO<sub>2</sub> can be understood to be formed due to interference between photons collected by the objective from different paths. The two major paths relevant here are sketched in Fig. 1(b). In path one (P<sub>1</sub>), photons are directly reflected off the sample and collected by the objective. In path two (P<sub>2</sub>), photons transfer into in-plane

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FIG. 1. (a) Schematics of the near-field optical study of WSe<sub>2</sub>. (b) Illustration of the experimental setup and two major pathways (P<sub>1</sub> and P<sub>2</sub>) where photons are collected by the top objective. (c–f) Selected nano-optical imaging data of a WSe<sub>2</sub> flake (thickness = 260 nm) taken at various excitation wavelengths ( $\lambda_0$ ). Here we plot the total counts of the photons collected by the objective normalized to that taken on the SiO<sub>2</sub>/Si substrate. The white dashed lines mark the edges of the WSe<sub>2</sub> flake. The two arrows in (d) mark the directions along which we took line profiles across the fringes on both WSe<sub>2</sub> and SiO<sub>2</sub> as plotted in Fig. 2(a). Scale bars in (c–f) represent 1  $\mu$ m.

propagative modes and scatter back to photons after reaching the sample edge. Note that the in-plane modes contributing to  $P_2$  are mainly those propagating normal to the sample edge [along the -x direction in Fig. 1(b)]. The photons scattered from in-plane modes propagating along other directions will not be efficiently collected by the top objective (Supplemental Material [23]). In addition to  $P_1$  and  $P_2$ , there are also other possible photon paths, but they play less significant roles here (Supplemental Material [23]). As will be discussed in detail below, these in-plane modes inside path P<sub>2</sub> on the sample side are a mixture of photons in air or SiO<sub>2</sub> and confined waveguide modes inside WSe2. The latter are enabled by the sub-diffraction-limit aperture of the NSOM tip, which generates a wide range of in-plane momenta (q). The phase difference between collected photons from paths  $P_1$  and  $P_2$  is determined by the distance (x) between the tip and the sample edge. Therefore when scanning the tip away from the sample edge, one expects interference fringes with periodicities that are equal to the wavelengths  $(\lambda_p)$  of the in-plane modes. The longest distance away from the edge that the fringes extend is determined by the propagation lengths  $(L_p)$  of these modes.

Based on the above picture, we are able to determine all the essential parameters of the in-plane modes by analyzing the fringe patterns. In Fig. 2(a), we plot the line profiles extracted perpendicular to the fringes of WSe<sub>2</sub> and SiO<sub>2</sub> along the arrows marked in Fig. 1(d) ( $\lambda_0 = 850$  nm). One can see that the fringe profile of WSe<sub>2</sub> consists of a number of oscillations that extend far away from the sample edge (x = 0). In order to estimate  $L_p$ ,

we plot in Fig. 2(b) a background-subtracted fringe profile of WSe<sub>2</sub> as well as calculated decay curves considering different  $L_{\rm p}$  (dashed curves, see Supplemental Material [23] for details about the calculation). The best match to the data is obtained when  $L_{\rm p} \approx 3 \,\mu {\rm m}$  (black dashed curves). As detailed below, the oscillations on WSe2 are due to a mixture of multiple in-plane modes, so our estimation produces an average  $L_p$  over all the modes launched by the NSOM tip. Similar analysis is also performed on data profiles taken at other  $\lambda_0$  (Fig. S4a [23]). Thus-obtained  $L_p(\lambda_0)$  is plotted in Fig. 2(c) as hollow squares, where one can see that  $L_p$  increases rapidly with  $\lambda_0$  above the A exciton wavelength ( $\lambda_{ex} \approx 790$  nm). The trend of the rapid increase projects to a huge  $L_p$  of tens of microns as  $\lambda_0$ approaches 900 nm. Therefore, a much larger crystal with a scale over 100  $\mu$ m is necessary to accurately determine  $L_p$ at wavelengths close to 900 nm. Nevertheless, the large  $L_p$  at these wavelengths is reflected by the weakly damped fringes shown in the data image [Fig. 1(c)] and profiles (Fig. S4a [23]) of our current sample with a practical size (Fig. S1b [23]). In Fig. 2(c), we also plot the theoretical calculation of the upper limit of  $L_p$  at our  $\lambda_0$  range (Supplemental Material [23]), which captures well the trend of the experimental data points.

From Fig. 2(a), we notice that the fringe profile of WSe<sub>2</sub> is complicated and appears to be a superposition of oscillations with different periodicities. In order to determine the periodicities accurately, we performed Fourier analysis on these real-space profiles. The outcomes are the q-space profiles [Figs. 2(d) and 2(e)], where the peaks correspond directly to the



FIG. 2. (a) Real-space fringe profiles of WSe<sub>2</sub> and SiO<sub>2</sub> at  $\lambda_0 = 850$  nm taken directly from Fig. 1(d) along the black and red arrows, respectively. (b) The same fringe profile of WSe<sub>2</sub> as (a) with background signal subtracted and the calculated decay curves obtained by assuming different propagation lengths ( $L_p$ ) (see Supplemental Material [23]). (c) Estimated  $L_p$  versus  $\lambda_0$  from data fitting (hollow squares) and theoretical calculation of the upper limit of  $L_p(\lambda_0)$  (black curve; see Supplemental Material [23]). The red arrow marks the A exciton wavelength ( $\lambda_{ex}$ ). (d) Momentum (q) profiles of WSe<sub>2</sub> and SiO<sub>2</sub> at  $\lambda_0 = 850$  nm obtained by Fourier analysis of the real-space fringe profiles shown in (a). (e) The q profiles of WSe<sub>2</sub> (black curves) at all  $\lambda_0$  obtained by Fourier analysis of the real-space fringe profiles (Fig. S4a [23]). The q profiles are displaced vertically for clarity. The unit of the q axis in (d,e) is the excitation far-field wave vector  $k_0 = 2\pi/\lambda_0$ . The vertical black dashed and dash-dotted lines in (d,e) mark the photon lines in air ( $q = k_0$ ) and SiO<sub>2</sub> ( $q = 1.46k_0$ ), respectively. The black and purple arrows in (d,e) mark the air and substrate modes. The blue, green, and red arrows in (d,e) mark, respectively, the TE<sub>2</sub>, TM<sub>1</sub>, and TE<sub>1</sub> waveguide modes inside WSe<sub>2</sub>. The orange arrows in (e) at low- $\lambda_0$  regime mark a broad hump feature that occurs due to the merging of the damped waveguide modes.

momenta ( $q_p = 2\pi/\lambda_p$ ) of the in-plane modes. From Fig. 2(d), one can see that the q profile of SiO<sub>2</sub> has one broad peak close to  $k_0 = 2\pi/\lambda_0$  indicating that they are mainly photons (see Supplemental Material [23] for more discussions about bare substrate modes). The q profile of WSe<sub>2</sub>, on the other hand, shows multiple peaks (marked with arrows). The two peaks close to  $k_0$  (black arrow) and  $n_{sub}k_0$  (purple arrow;  $n_{sub} = 1.46$ is the refractive index of  $SiO_2$ ) are the air and substrate modes, respectively. The field of the two modes is not confined inside  $WSe_2$  but extends to air or substrate [24]. In addition to the two modes, there are three more peaks above  $1.46k_0$  (blue, green, and red arrows), which we label as various waveguide modes inside WSe2 according to our dispersion analysis (see discussions below). Note that the mode at  $q_p = 1.6k_0$  (blue arrow) merges with the adjacent substrate mode (purple arrow) and becomes a shoulder feature. The highest  $q_p$  of these waveguide modes is close to  $2.5k_0$ , corresponding to a  $\lambda_p$  of about 350 nm. In order to study the  $\lambda_0$  dependence of the in-plane modes inside WSe<sub>2</sub>, in Fig. 2(e) we plot a complete set of q profiles of WSe<sub>2</sub> at all  $\lambda_0$ . Here, one can see that all the modes (marked with arrows) evolve systematically with  $\lambda_0$ . As  $\lambda_0$  decreases from 900 towards 800 nm, all the modes shift to larger qindicating smaller mode wavelength ( $\lambda_p$ ). When  $\lambda_0$  reaches the A exciton wavelength ( $\lambda_{ex} \approx 790$  nm) and below, the air and substrate modes (black and purple arrows) shift abruptly to lower q. The waveguide modes inside WSe<sub>2</sub> (blue, green, and red arrows), on the other hand, become damped and are thus not clearly distinguishable. As  $\lambda_0$  approaches 740 nm away from the A exciton, we observe a broad hump feature below  $q = 2.0k_0$  (orange arrows in Figs. 2(e) and S4b [23]). Such hump features are formed due to the merging of all the damped waveguide modes inside WSe<sub>2</sub> (see discussions below).

To gain insights into these modes, in Figs. 3(a), 3(b), 3(d), and 3(e) we plot the calculated  $\lambda_0$ - and *q*-dependent dispersion diagrams of the entire sample/substrate system. Because the aperture-type NSOM probe induces strong enhancement of both in-plane and out-of-plane fields, it can couple to both transverse electric (TE) and transverse magnetic (TM) modes [25,26]. Therefore we considered both TE and TM polarizations in our calculations. The dispersion diagrams in Figs. 3(a) and 3(d) are calculated with the realistic in-plane dielectric function of WSe<sub>2</sub> from the literature [27], while those in Figs. 3(b) and 3(e) are calculated with artificial optical constants considering only the *A* excitons (Fig. S3 [23]). Details about the dispersion calculation and the optical constants of WSe<sub>2</sub> are introduced in the Supplemental Material [23].



FIG. 3. (a,b) Calculated color maps about the imaginary part of the *s*-polarized reflection coefficient  $\text{Im}[r_s(q, \lambda_0)]$  of the WSe<sub>2</sub> sample (thickness = 260 nm) with both realistic and artificial optical constants (Fig. S3 [23]). (c) Calculation of the *y*-direction electric field ( $E_y$ ) of TE<sub>0</sub>, TE<sub>1</sub>, and TE<sub>2</sub> modes at  $\lambda_0 = 900$  nm. (d,e) Calculated color maps of the imaginary part of the *p*-polarized reflection coefficient Im[ $r_p(q, \lambda_0)$ ] of the WSe<sub>2</sub> sample with both realistic and artificial optical constants. (f) Calculation of the *y*-direction magnetic field ( $H_y$ ) of TM<sub>0</sub> and TM<sub>1</sub> modes at  $\lambda_0 = 900$  nm. The data points in (a,d) mark the peak positions extracted from the Fourier *q* profiles in Fig. 2(e). To avoid blocking the color map, we only show data points at selected wavelengths (900, 880 ··· 740 nm) here. The unit of the *q* axis in (a,b,d,e) is  $k_0$ . The bright curves in (a,b,d,e) above  $q = 1.46k_0$  represent various waveguide modes inside WSe<sub>2</sub> as labeled in the figures. The horizontal dashed lines in (a,b,d,e) mark the wavelength for the *A* exciton of WSe<sub>2</sub> ( $\lambda_{ex}$ ). The horizontal solid lines in (c,f) mark the air/WSe<sub>2</sub> and WSe<sub>2</sub>/SiO<sub>2</sub> interfaces. The vertical dashed lines in (c,f) mark  $H_y = 0$  and  $E_y = 0$ , respectively.

The bright curves shown in these dispersion plots correspond to various in-plane modes inside the system, among which we label the waveguide modes of WSe<sub>2</sub> as TE<sub>0</sub>, TE<sub>1</sub>, TE<sub>2</sub>, TM<sub>0</sub>, and TM<sub>1</sub> modes based on the calculated field distributions [Figs. 3(c) and 3(f)]. There are also modes appearing at the low-q regime close to  $k_0$  and 1.46 $k_0$  in the TM dispersion maps, which are air and substrate modes, respectively. The data points overlaid on top of the color maps in Figs. 3(a) and 3(d) are the q positions for the air mode (black), substrate mode (purple), and various WSe<sub>2</sub> waveguide modes (red, blue, and green) extracted from the Fourier q profiles in Fig. 2(e). Note that we only show data points at selected  $\lambda_0$  in Figs. 3(a) and 3(d) to avoid blocking the color map.

From Fig. 3 one can see that all the modes show distinct dispersion properties due to their coupling with the *A* excitons  $(\lambda_{ex})$  in WSe<sub>2</sub> (marked with white dashed lines in the dispersion plots). More specifically, when approaching excitons from higher-excitation wavelengths  $(\lambda_0 > \lambda_{ex})$  all the waveguide modes inside WSe<sub>2</sub> shift to higher *q*, which can be seen clearly from both experimental data points and calculated dispersion color plots with realistic optical constants [Figs. 3(a) and 3(d)]. At lower-excitation wavelengths  $(\lambda_0 < \lambda_{ex})$ , on the other hand, all the waveguide modes suffer from damping due

to adjacent B excitons or band-edge absorption of WSe<sub>2</sub> (Fig. S3 [23]). As a result, lower branches of these waveguide modes  $(\lambda_0 < \lambda_{ex})$  are not clearly resolved experimentally. Instead, they merge together as one broad hump feature [Fig. 2(e)]. Calculations considering only the A excitons more clearly show the bottom branches [Figs. 3(b) and 3(e)]. From the dispersion color plots [Figs. 3(a), 3(b), 3(d), and 3(e)], one can see clear anticrossing behaviors above and below  $\lambda_{ex}$  for all the waveguide modes, which are signatures of the formation of exciton polaritons- hybrid modes between photons and excitons [28-31]. Recently, exciton polaritons in TMDCs drew a lot of research interest [32–35] and were observed by far-field spectroscopy with cavity coupling methods [34,35]. Our real-space nanoimaging data clearly capture the high- $\lambda_0$ (or low-energy) portion of the polariton dispersion of WSe<sub>2</sub> [Figs. 3(a) and 3(d)]. In addition to the waveguide modes inside WSe<sub>2</sub>, the air and substrate modes [black and purple data points in Fig. 3(d)] also couple to the WSe<sub>2</sub> excitons and thus become discontinuous above and below  $\lambda_{ex}$ . For the bare SiO<sub>2</sub>/Si substrate, on the other hand, only straight photon modes between  $k_0$  and  $1.46k_0$  can be seen in their Fourier q profiles (Fig. S5b [23]) and also the calculated dispersion diagrams (Fig. S6 [23]). Note that the  $TE_0$  and  $TM_0$ 



FIG. 4. (a) Nano-optical imaging data of a 120-nm-thick WSe<sub>2</sub> thin flake taken at  $\lambda_0 =$ 850 nm. The white dashed line marks the edge of the WSe<sub>2</sub> flake. Scale bar represents 700 nm. (b) Real-space line profile (top panel) taken along the white arrow in (a) and the corresponding q profile (bottom panel) obtained from Fourier analysis. The arrows here mark the positions of two waveguide modes above  $q = 1.46k_0$ . (c,d) Calculated thickness- and momentum-dependence color maps of  $Im(r_p)$  and  $Im(r_s)$  for TM and TE modes, respectively. The data points overlaid on top of the color maps mark the mode positions of WSe<sub>2</sub> waveguide modes extracted from mode analysis in Figs. 2, 4, S7, and S8 [23].

modes of the 260-nm-thick WSe<sub>2</sub> [Figs. 3(a) and 3(d)] are not clearly resolved experimentally from the Fourier q profiles [Figs. 2(d) and 2(e)] due to their narrow linewidths that are beyond the resolution limit of our NSOM probe (Supplemental Material [23]).

Finally, we wish to discuss the dependence of the waveguide modes with the flake thickness. In Fig. 4(a), we plot the near-field image of a 120-nm-thick WSe<sub>2</sub> flake taken at  $\lambda_0 = 850$  nm. Following the same procedure as described above, we plot in Fig. 4(b) the real-space fringe profile (top panel) and the corresponding Fourier q profile (bottom panel) of WSe<sub>2</sub>. Unlike the 260-nm-thick flake discussed above, the current thinner sample has only two peaks at  $q \approx 1.6k_0$  and  $2.4k_0$  (gray and yellow arrows) above the far-field photon line  $(q = k_0)$ . Similar analysis was also done on data taken from a 70-nm-thick flake (Fig. S7 [23]), where the two peaks shift down to  $q \approx 1.5k_0$  and  $2.0k_0$ , respectively. As the sample gets even thinner down to a few nanometers (Fig. S8 [23]), the fringes appear to be sinusoid indicating that only single mode is involved. For example, the WSe<sub>2</sub> samples with a thickness of 8 nm and 4 nm have mode momenta of  $q \approx 1.5k_0$  and  $1.3k_0$ , respectively (Supplemental Material [23]).

To understand the observed thickness dependence, we plot in Figs. 4(c) and 4(d) the calculated thickness- and momentumdependent color maps of both TE and TM modes at  $\lambda_0 =$ 850 nm, where the bright curves represent various modes in the system. The data points here are mode positions above q =1.46 $k_0$  extracted from mode analyses from multiple samples (Figs. 2, 4, S7, and S8 [23]), and they are consistent with the calculated color plots. From Figs. 4(c) and 4(d), one can see that both the mode position and the number of modes evolve systematically with the flake thickness. For the 260-nm-thick flake, there are five waveguide modes above  $1.46k_0$ , among which the TE<sub>1</sub>, TE<sub>2</sub>, and TM<sub>1</sub> modes are clearly resolved by our Fourier analysis [Fig. 2(d)], while in the case of the WSe<sub>2</sub> flakes with a thickness of 120 and 70 nm, there are two waveguide modes (TE<sub>0</sub> and TM<sub>0</sub> modes) above  $1.46k_0$ [Figs. 4(c) and 4(d)]. The TE<sub>1</sub> mode here in the 120-nm-thick flake is below  $1.46k_0$ , so it merged with the air and substrate modes. When the sample gets even thinner (a few nanometers thick), only the TE<sub>0</sub> mode exists, which is captured by our nano-optical imaging data (Fig. S8 [23]).

With state-of-the-art near-field optical microscopy, we performed a nano-optical imaging study of waveguide modes inside WSe<sub>2</sub>. By recording and analyzing the interference fringes of these modes, we were able to extract both their wavelengths and propagation lengths. We found that the wavelengths of these modes are as low as 300 nm that are two to three times smaller than the excitation laser wavelengths, and they can propagate over tens of microns below the A exciton energy. Moreover, we observed signatures of coupling between waveguide photon modes with A excitons in WSe<sub>2</sub>. The coupling shifts the waveguide modes towards higher momenta below the A exciton energy. As the excitation laser energy increases above the A exciton energy, all waveguide modes become strongly damped due to adjacent B excitons and band-edge absorption. Our work opens up a regime for studying nanoscale light-matter interactions in TMDCs and thus provides guidelines for future applications of this class of materials in nanophotonics and optoelectronics.

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